502468814 08/22/2013

PATENT ASSIGNMENT

Electronic Version v1.1 Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
Vinay Nair	05/23/2013
Lars Heineck	05/24/2013

RECEIVING PARTY DATA

Name:	NANYA TECHNOLOGY CORP.
Street Address:	Hwa-Ya Technology Park 669, Fuhsing 3 Rd., Kueishan
City:	Tao-Yuan Hsien
State/Country:	TAIWAN

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	13974032

CORRESPONDENCE DATA

Fax Number: 7039974517

Correspondence will be sent via US Mail when the fax attempt is unsuccessful.

Phone: 3027291562

Email: Patent.admin.uspto.cr@naipo.com

Correspondent Name: WINSTON HSU
Address Line 1: P.O.BOX 506

Address Line 4: Merrifield, VIRGINIA 22116

NTCP0520USA
KATE YEH
/KATE YEH/
08/22/2013

Total Attachments: 4

source=1730830#page1.tif source=1730830#page2.tif source=1730830#page3.tif source=1730830#page4.tif

> PATENT REEL: 031066 FRAME: 0879

TOH \$40.00 1397403

ASSIGNMENT OF INVENTION

In consideration of the payment by ASSIGNEE to ASSIGNOR of the sum of One Dollar (\$1.00), the receipt of which is hereby acknowledged, and for other good and valuable consideration.

Name:	Vinay Nair	Nationality:	IN
Name:	Lars Heineck	Nationality:	DE
Hereby sells, as ASSIGNEE(S)	signs and transfers to		
Name:	NANYA TECHNOLOGY CORP.		
Address:	: Hwa-Ya Technology Park 669, Fuhsing 3 Rd., Kueishan, Tao-Yuan Hsien, Taiwan, R.O.C.		
and the succes any and all imp	sors and assignees of the ASSIGN rovements which are disclosed in	EE the entire right, title, and the invention entitled:	nd interest in and to
"METHO	FOR SEMICONDUCTOR CROSS PI	TCH DOUBLED PATTERNING	PROCESS"
Which is foun	d in :		
(a) <u>+</u>	U.S. patent application executed or	n even date	
(b)	(b) U.S. patent application executed on		
(c)	U.S. application serial no		- Constant
(d)1	patent no.	issued	
(e)]	nternational application no.		

Assignment, Page 1 of 2

NPO#NTC-P0520-USA:0 CUST#M2011-0820-US

ASSIGNOR(S) (Inventors):

F#NPO-P0002E-US1 DSC0-102U005225

PATENT

and, in and to, all Letters Patent to be obtained for said invention by the above application or any continuations, continuation-in-part, divisions, renewals, substitutes, or extensions thereof, and as to Letters Patent any reissue or re-examination thereof

ASSIGNOR hereby covenants that no assignment, sale, agreement or encumbrance has been or will be made or entered into which would conflict with this assignment;

ASSIGNOR further covenants that ASSIGNEE will, upon its request, be provided promptly with all pertinent facts and documents relating to said invention and said Letters Patent and legal equivalents as may be known and accessible to ASSIGNOR and will testify as to the same in any interference, litigation or proceeding related thereto and will promptly execute and deliver to ASSIGNEE or its legal representatives any and all papers, instruments or affidavits required to apply for, obtain, maintain, issue and enforce said application, said invention and said Letters Patent and said equivalents thereof which may be necessary or desirable to carry out the proposes thereof.

IN WITNESS WHEREOF, We have hereunto set hand and seal this 5/23/2013 (Date of signing). (读者明人房必答者上列日期·)

(Type name of inventor)	Signature of INVENTOR
Vinay Nair	Vine Me
Lars Heineck	V

Assignment, Page 2 of 2

NPO#NTC-P0520-USA:0 CUST#M2011-0820-US F#NPO-P0002E-US1 DSC0-102U005225

ASSIGNMENT OF INVENTION

In consideration of the payment by ASSIGNEE to ASSIGNOR of the sum of One Dollar (\$1.00), the receipt of which is hereby acknowledged, and for other good and valuable consideration.

ASSIGNO	R(S) (Inventors):		
Name:	Vinay Nair	Nationality: IN	
Name:	Lars Heineck	Nationality: DE	
Hereby sells,	, assigns and transfers to		
ASSIGNEE	(S):		
Name:	NANYA TECHNOLOGY CORP.		
Addres	: Hwa-Ya Technology Park 669, Fuhsing 3 Rd., Kueishan, Tao-Yuan Hsien, Taiwan, R.O.C.		
any and all in	mprovements which are disclos		
"METH	HOD FOR SEMICONDUCTOR CRO	SS PITCH DOUBLED PATTERNING PROCESS"	
Which is fo	und in :		
(a) U.S. patent application executed on even date			
(b) U.S. patent application executed on			
		issued	
	_International application no.		

Assignment, Page 1 of 2

NPO#NTC-P0520-USA:0 CUST#M2011-0820-US

F#NPO-P0002E-US1 DSC0-102U005225 and, in and to, all Letters Patent to be obtained for said invention by the above application or any continuations, continuation-in-part, divisions, renewals, substitutes, or extensions thereof, and as to Letters Patent any reissue or re-examination thereof

ASSIGNOR hereby covenants that no assignment, sale, agreement or encumbrance has been or will be made or entered into which would conflict with this assignment;

ASSIGNOR further covenants that ASSIGNEE will, upon its request, be provided promptly with all pertinent facts and documents relating to said invention and said Letters Patent and legal equivalents as may be known and accessible to ASSIGNOR and will testify as to the same in any interference, litigation or proceeding related thereto and will promptly execute and deliver to ASSIGNEE or its legal representatives any and all papers, instruments or affidavits required to apply for, obtain, maintain, issue and enforce said application, said invention and said Letters Patent and said equivalents thereof which may be necessary or desirable to carry out the proposes thereof.

IN WITNESS WHEREOF, We signing). (請發明人務必簽署上列日期。)	have hereunto set hand and seal this	(Date of
(Type name of inventor)	Signature of INVENTOR	
<u>Vinay Nair</u> Lars Heineck	(go Pel Hall	05/24/2013

Assignment, Page 2 of

NPO#NTC-P0520-USA:0 CUST#M2011-0820-US

F#NPO-P0002E-US1 DSC0-102U005225

RECORDED: 08/22/2013